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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani, et al. Art Unit : 2815
Serial No. : 09/379,702 Examiner : Eugene Lee
Filed : August 24, 1999 Confirmation No.: 1613
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

NOTICE OF APPEAL

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the action dated February 4, 2004, finally rejecting claims 45-64.

A petition for an extension of time under 37 CFR §1.136 to extend the time to respond to the final rejection for a second month to and including July 6, 2004 (July 4, 2004 was a Sunday and July 5, 2004 was a holiday) is enclosed.

A check in the amount of \$640 for the appeal fee (\$330) and the extension of time fee for the second month only (\$310) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: July 6, 2004



John F. Hayden
Reg. No. 37,640

Customer No. 26171
Fish & Richardson P.C.
1425 K Street, N.W., 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

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02 FC:1252 310.00 DP